

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Katsumi MIYATA, et al.**

Serial Number: **NEW**

Filed: **January 5, 2000**



For: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME  
INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

January 6, 2000

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the reference listed on the attached PTO-1449.

A copy of the reference is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, WESTERMAN, HATTORI  
MCLELAND & NAUGHTON

William F. Westerman

Reg. No. 29,988

Atty. Docket No.: **991527**  
Suite 1000, 1725 K Street, N.W.  
Washington, D.C. 20006  
Tel: (202) 659-2930  
Fax: (202) 887-0357  
WFW/llf  
Enclosures: PTO-1449; Reference (1).